

TIA

MEMS Resonator

Lamé mode resonator

The anchors of Lamé mode

resonator move away from main structure, different from

C-C Beam, that suppresses

energy loss through them.

Anchor

Criteria.

Suspension

region

 $V_d \bigotimes_{\text{port}}^{\text{Drive}}$ 

Amplitude

 $\sim$ 

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time

# CMOS PHASE-LOCKED LOOP WITH INTEGRATED MEMS RESONATOR

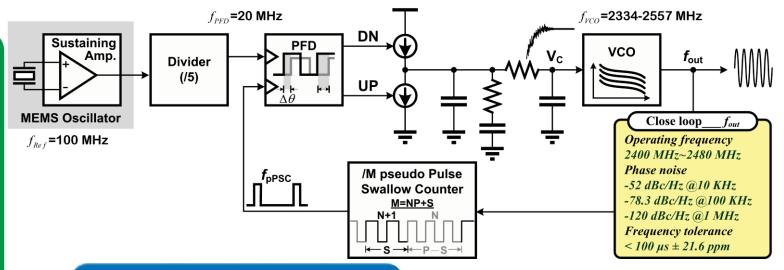


### PFD , Charge Pump

The type-IV PFD, we chosen that because of its detecting range covers  $\pm 2\pi$ . Our CP has high linearity. The dead zone, PFD+Charge Pump, had eliminated.

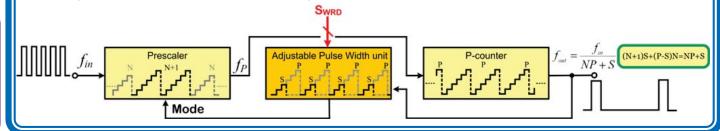
## vco

The loss of inductor was compensated by cross-couple pairs, the wide tune and the fine tune were controlled through  $V_b$  and  $V_c$ , respectively.



#### pseudo Pulse Swallow Counter

We applied a adjustable pulse width unit to replace S-counter, that has the same performance and more simple than the traditional PSC.



#### Contribute to Tomorrow's Technology

Ring oscillator topology

The oscillator uses MEMS resonator

as its frequency selective tank, there will be oscillate if the loop gain  $L(j\omega)$  at  $\omega_a$  matched the Barkhausen's

#### applied microwave technology group @ NTU-GIEE